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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (Use as many sheets as necessary)		<b>Complete if Known</b>			
		Application Number	10/648,052		
		Filing Date	August 26, 2003		
		First Named Inventor	U. Balachandran et al.		
		Art Unit	1754		
		Examiner Name	Colleen P. Cooke		
Sheet	1	of	2	Attorney Docket Number	ANL 273

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
CL		B.W. Kang, A. Goyal et al., Comparative Study of Thickness Dependence of Critical Current Density ..., J. Mater. Res. Vol. 17, No. 7, July 2002	
		V.A. Maroni, K. Venkataraman et al., Nondestructive Analysis of Phase Evolution and Microstructure..., Physica C 382 (2002) 21-26	
		R.M. Baurceanu, V.A. Maroni et al., Investigation of a Multi-Set-Point First Heat Treatment..., Supercond. Sci. Technol. 15 (2002) 1167-1175	
		R.M. Baurceanu et al., Time Evolution of Phase Composition and Microstructure..., Supercond. Sci. Technol. 15 (2002) 1160-1166	
		Y.L. Tang, D.J. Miller et al., Improved Microstructure in Ag/Bi-2223..., Supercond. Sci. Technol. 15 (2002) 1-7	
		J.H. Je, H. You et al., Detection of a Pd-Ni Interlayer at the Pd/Ni Interface..., Physica C 383 (2002) 241-246	
		U. Balachandran et al., Development of High-Temperature Superconductors..., Abstract of Invited Keynote Talk at Brazilian Physical Soc., Recife, Brazil, Nov. 5-8, 2002	
		U. Balachandran, B. Ma et al., Development of Coated Conductors by Inclined Substrate Deposition, Int. Sym. on Supercond., Japan 11/2002	
		S. Tsukui, R.E. Koritala et al., Oxygen and Cation Diffusion in YBCO Coated Conductors, Physica C 392-396 (2003) 841-846	
CL		B. Ma, M. Li et al., Pulsed Layer Deposition of YBCO Films on ISD MgO Buffered Metal Tapes, Supercond. Sci. Technol. 16 (2003) 464-472	

Examiner Signature	<i>Colleen P. Cooke</i>	Date Considered	9-14-05
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CL		M. Li, B. Ma et al., Pulsed Laser Deposition of c-axis Untilted YBCO Films on c-axis tilted ISD MgO Buffered Metallic Substrate, Physica C 387 (2003) 373-381	
		B. Ma, M. Li et al., Inclined Substrate Pulsed Laser Deposition..., Abstract from American Ceramic Society 105th Ann. Meeting & Exposition, Nashville, Tenn., April 27-30, 2003	
		P.S. Shanakar et al. Residual Stress Measurements in YBCO-Coated Conductors, Abstract at 105th Amer. Ceramic Soc. Mtg. Tenn. April 2003	
		Y.X. Zhou, M. Mironova et al., New Seeding Method for Texturing Y-Ba-Cu-O Bulk, 105th Ann. Meeting Amer. Cera. Soc. TN, April 2003	
CL		R.M. Baurceanu, S.E. Dorris et al., Copper Additions to Silver Substrates for YBa <sub>2</sub> Cu <sub>3</sub> O <sub>7</sub> ..., Abstract at 105th Mtg. Expo. Amer. Ceramic Soc. 2003	

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